

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Jin-Xing Li

Serial No.: 10/528,765

Filed: December 1, 2006

For: Two Layer LTO Temperature Oxide Backside Sealer for a Wafer

Attorney Docket No.: WSAG 0107 PUSA

Group Art Unit: 1784

Examiner: Jonathan C. Langman

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. § 1.97(b)**

Mail Stop Amendment
Commissioner for Patents
U.S. Patent & Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and §§ 1.97-1.98, the references listed and identified on the attached Forms PTO/SB08A and/or SB08B are being submitted herewith for consideration by the Examiner. This statement is being filed in accordance with 37 C.F.R. § 1.97(b).

While this Statement is being filed in compliance with the duty of disclosure, citation of the listed references is not to be construed as an admission that any of the references are "material" as defined under 37 C.F.R. § 1.56(b).

Accompanying the Information Disclosure Statement is the statement of Dr. Wolfgang Staudacher describing the content of the references cited in the Information Disclosure Statement.

No copies of the listed U.S. patent references or the listed U.S. patent application publication references have been included herewith pursuant to 37 C.F.R. § 1.98(a)(2). All other references have been provided as required. Consideration and entry into the record of the listed references is respectfully requested.

Respectfully submitted,

Jin-Xing Li

By: /James W. Proscia/
James W. Proscia
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Date: December 1, 2010

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

JIN-XING LI ET AL.

Serial Number: 10/528765

Group Art Unit: 1794

Filed: September 18, 2003

For: Two layer LTO backside seal for a wafer

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstr.4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the document enumerated on the enclosed Form PTO-1449 and attached thereto may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art reference US 5,834,363 enumerated on PTO Form-1449:

US 5,834,363 came to my attention during a search for documents disclosing a correlation between LTO deposition conditions and the stress of the deposited LTO layer.

Signed November 30, 2010.


Dr. Wolfgang Staudacher